### 1 Formula

## De Broglie Hypothesis

$$p = mv = \frac{h}{\lambda} = k\frac{h}{2\pi}$$
 
$$k = \frac{2\pi}{\lambda}$$
 
$$L = n\frac{\lambda}{2}$$
 
$$p = \frac{hn}{2L}$$

Bragg

$$2dsin\theta = n\lambda$$

**Mass Action Law** 

$$n_i^2 = np$$

Conductivity

$$\sigma = q(\mu_h p + \mu_e n)$$

Depletion Region Width

$$\epsilon E = qN_D x_p$$

$$\epsilon E = qN_A x_n$$

$$W = x_n + x_p = \frac{\epsilon E_{max}}{q} \left(\frac{1}{N_D} + \frac{1}{N_A}\right)$$

Speed of CMOS

$$au \propto \frac{L^2}{\mu}$$

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### 2 Definition

# 3 Tao Lu

# 3.1 Derive $I_D$

- 1. Mos capacitor:  $Q = CV = -C_0(V_G V_T V_x) = qndz$
- 2. Current definition I=qnvA, where v is given by  $v=\mu E,\,A=Wdz$
- 3. Substitute,  $I = -C_0(V_G V_T V_x)\mu EW$

$$4. E = -\frac{dV_x}{dx}$$

5. 
$$I = C_0(V_G - V_T - V_x)\mu \frac{dV_x}{dx}W$$

6. Multiplied by dx, integration, find  $I_D$ 

#### 3.2 Derive Threshold Voltage

1. 
$$V_{ox} = \frac{V_G - V_S}{t_{ox}}, V_G = V_{ox}t_{ox} + \phi_s$$

2. Apply Gauss's Law, get 
$$E_s = \frac{N_A t_s q}{\epsilon_0 \epsilon_s}$$

3. V is the area below E 
$$t_s = \frac{\phi_s}{E_s}$$

4. 
$$\epsilon_{ox}E_{ox} = \epsilon_s E_s$$

5. Find 
$$V_G$$

#### 3.3 Find Depletion Region Width

- 1. Find the point where  $E = E_{max}$
- 2. Apply Gauss's Law  $\int DdA = Q = x_p qAN_A = x_n qAN_D$
- 3.  $D = \epsilon E_{max}$
- 4.  $V_{bi} = \frac{1}{2}(x_n + x_p)E_{max}$